



Docket No.: 50099-184

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Masato FUJINAGA :
Serial No.: : Group Art Unit:
Filed: October 16, 2001 : Examiner:
For: HIGH-FREQUENCY SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING THE SAME

CLAIM OF PRIORITY AND
TRANSMITTAL OF CERTIFIED PRIORITY DOCUMENT

Commissioner for Patents
Washington, DC 20231

Sir:

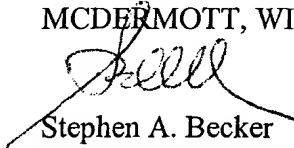
In accordance with the provisions of 35 U.S.C. 119, Applicant hereby claims the priority of:

Japanese Patent Application No. 2000-349807, filed November 16, 2000

cited in the Declaration of the present application. A certified copy is submitted herewith.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


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50099-184
Masato Fujinaga
October 16, 2001

日 本 国 特 許 庁

PATENT OFFICE
JAPANESE GOVERNMENT

McDermott, Will & Emery

別紙添付の書類に記載されている事項は下記の出願書類に記載されて
いる事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed
with this Office.

出 願 年 月 日
Date of Application:

2000年11月16日

出 願 番 号
Application Number:

特願2000-349807

願 人
Applicant(s):

三菱電機株式会社

2000年12月 8日

特許庁長官
Commissioner,
Patent Office

及 川 耕 造

